

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date February 11, 2009

In re the Application of

Hideki SATO

Application No.: 10/594,458

Filed: September 26, 2006

For: METHOD FOR EVALUATING CRYSTAL DEFECTS OF SILICON WAFER



Group Art Unit: 1792

Examiner: L. VINH

Docket No.: 129546

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired December 15, 2008, an extension of time for a period of two months is hereby requested. Attached hereto is our Check No. 215097 in the amount of \$490 in payment for:

 Extension fee for response within first month pursuant to §1.136(a) (\$130.00)

X Extension fee for response within second month pursuant to §1.136(a) (\$490.00)

 Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1,110.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

William P. Berridge
Registration No. 30,024

Nicolas A. Brentlinger
Registration No. 2623241 NDAF1 08000143 10594458

02 FC:1252

490.00 0P

WPB:NAB/kjl

OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461